

## INFORMATION DISCLOSURE STATEMENT

Applicant : Hayashi et al.  
App. No : 10/565,696  
Filed : January 24, 2006  
For : RESIN FOR RESIST, POSITIVE  
RESIST COMPOSITION, AND  
METHOD OF FORMING RESIST  
PATTERN  
Examiner : Huhn, Richard A.  
Art Unit : 1796

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I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

June 2, 2009

(Date)

Neil S. Bartfeld, Ph.D., Reg. No. 39,901

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 6 (six) references to be considered by the Examiner. Also enclosed are 4 (four) foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed after the mailing date of a final action or after the mailing date of a Notice of Allowance. This Statement is accompanied by the fee set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON &amp; BEAR, LLP

Dated: 6/2/09By: Neil S. Bartfeld

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